

# Power Converters

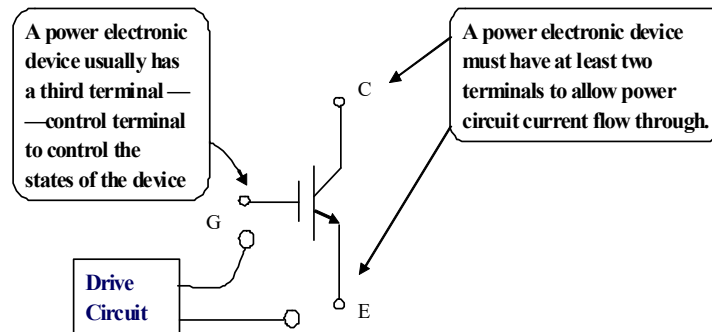
## ***Power Transistors***

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## Power BJT

## Power Transistor

- Power Transistor is a controlled Device



3

## Power Transistor

- Two types of transistor are extensively used in power switching circuits: bipolar junction transistor (BJT) and Metal Oxide Semiconductor Field Effect Transistor (MOSFET).
- The BJT consists of a *pn*p or *n*p*n* single-crystal silicon structure.
- It operates by the injection and collection of minority carriers, both electrons and holes, and is therefore termed a '*Bipolar Transistor*'.

4

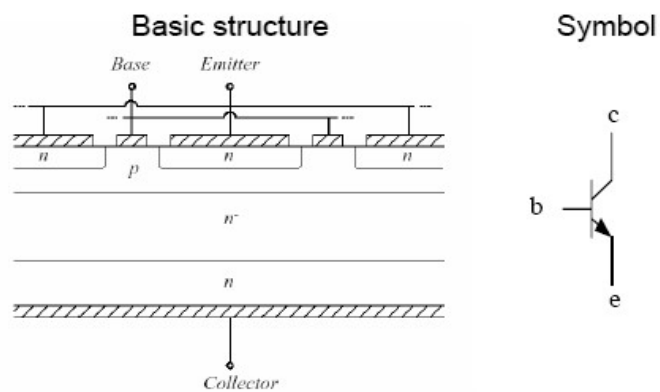
## Power Transistor

- The MOSFET depends on the voltage control of a depletion width, it is therefore a *Uni-polar Transistor*.
- Unlike the BJT, the MOSFET is a majority carrier device and therefore does not exhibit minority carrier storage delays, so switching times of the MOSFETs are ultra fast.

5

## Power BJT Structure

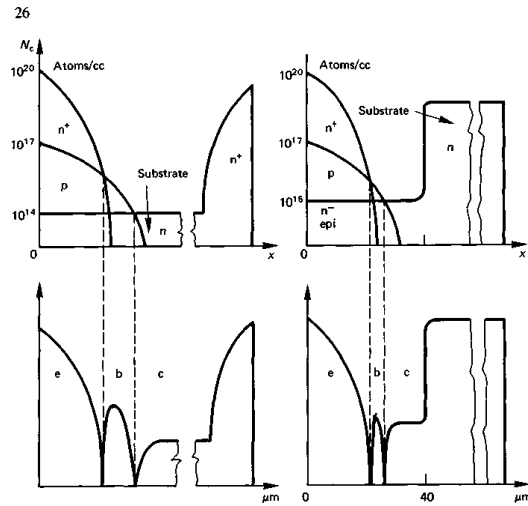
- Power BJT can handle high voltage and large current.



6

## Power BJT doping

A typical high-voltage triple-diffused transistor doping profile is shown below



7

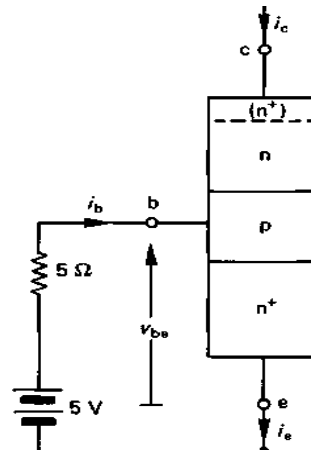
## Power BJT

- The n-collector region is the initial high-resistivity silicon material and the collector n<sup>+</sup> diffusion is performed first, usually into both sides.
- One n<sup>+</sup> diffusion is lapped off and the p-base and n<sup>+</sup> emitter diffusions are sequentially performed.

8

## Power BJT Operation

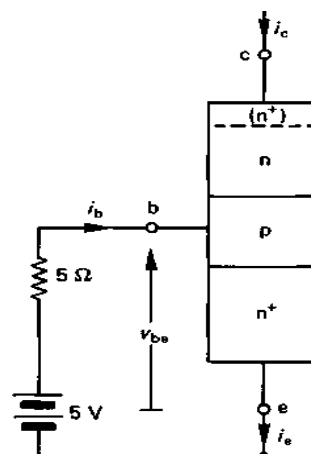
- A simple and qualitative view of the bipolar power switching transistor.
- **n**pn bipolar transistor connected in the common *emitter* configuration.



9

## Power BJT Operation

- In this configuration, injection of electrons from the lower  $n^+p$  junction into the centre  $p$ -region supplies minority carrier electrons to participate in the reverse current through the upper  $np$  junction.



10

## Power BJT Operation

- The  $n^+$  region which serves as the source of injected electrons is called the *emitter* and forms the emitter junction with the *p-base*, while the n-region into which electrons are swept by the reverse bias np junction is called the *collector* and, with the p-base, forms the collector junction

11

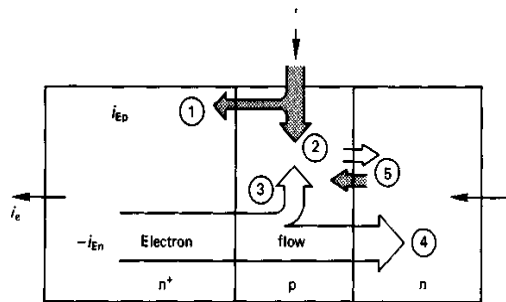
## Power BJT Operation

- To have a 'good' npn transistor almost all the electrons injected by the emitter into the base should be collected.
- Thus the p-base region should be narrow and the electron minority carrier lifetime should be long to ensure that the average electron injected at the emitter will diffuse to the collector *scl* without recombining in the base.
- The average lifetime of electrons in the p-base increases as the p-base concentration decreases, that is as the hole concentration decreases.

12

## Power BJT Operation

- The fraction of electrons which make it across to the collector is called the *base transport factor*,  $b_{te}$ .
- If we neglect the saturation current at the collector, component 5 in figure below, and such effects as space charge layer recombination, then  $i_c = b_{te} i_{En}$  where  $i_{En}$  is the electron component of the total emitter current  $i_e$ .



13

## Power BJT Operation

- Electrons lost to recombination in the p-base must be re-supplied through the base contact.
- It is also required that the emitter junction carrier flow should be composed almost entirely of electrons injected into the base, rather than holes crossing from the base region to the emitter.
- Any such holes must be provided by the base current, which is minimised by doping the base region lightly compared with the emitter such that an n<sup>+</sup>p emitter results.

14

## Power BJT Operation

- Such a junction is said to have a high *injection efficiency*.
- Holes swept into the base at the reverse-biased collector junction because of thermal generation in the collector must also be accounted for by the base current.
- This base current component is generally very small in high-voltage transistors when in the on-state since the collector space electric field is small.

15

## Power BJT Operation

- In the common emitter configuration, the ratio between the base current  $I_b$  and the collector current  $I_c$  is of practical importance.
- Since the base current is the difference between the emitter and the collector current.
- The factor  $\beta$ , relating the collector current to the base current, is defined as the base-to-collector *current amplification factor*.
- If  $\alpha$  is near unity,  $\beta$  is very large, implying the base current is very small compared with the collector current.

16



## Power BJT Operation

- In power switching applications a transistor is controlled in two states: the *off-state* and the *on-state*.
- Ideally the transistor should appear as a short circuit when on and an open circuit when in the off-state.
- Furthermore the transition time between these two states is ideally zero. In reality, transistors only approximate these requirements.

17

## Power BJT Operation

- The two operational states for the power switching transistor are defined as follows.
- **Cut-off region:** In this region the emitter junction is not injecting; hence only leakage current flows.
- **The saturation:** In traversing from the off-state to the saturated state the transistor passes through the linear operating region, where the collector junction voltage changes from a large reverse bias to a forward bias state.

18

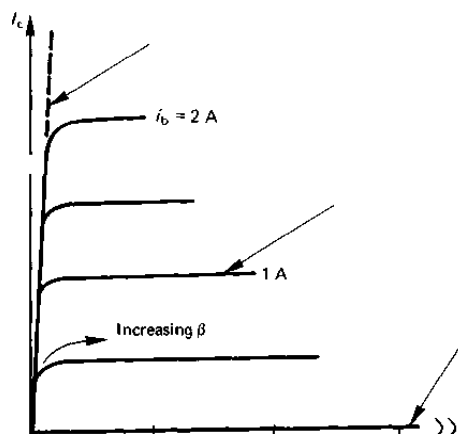
## Power BJT Operation

- Both junctions are forward-biased, termed *saturated*, and the collector-to-emitter voltage is almost zero, high current is able to flow.
- This saturated situation represents the switched-on hard mode, and over-saturation exists.
- The gain  $\beta$  is a minimum in the saturated mode since the neutral base width between the two forward-biased *scf's* is at a maximum.

19

## Power BJT Characteristics

The typical BJT collector output characteristics are shown below which illustrates the various BJT operating regions.



20

## Power BJT

### *Current Gain*

- A number of electrical phenomena are of particular importance to the high-voltage, power switching *BJT*.
- The characteristics to be considered are as a result of the device structure and geometry.
- The gain of a power transistor falls off at both very low and very high current levels.
- At low currents the gain decreases as a result of generation recombination.

21

### *Conductivity Modulation*

- At high currents, as the concentration of excess electrons in the base becomes large, the matching excess hole concentration can become greater than the base doped level.
- A balance of holes and electrons must occur in order to maintain a neutral base region.
- Thus holes in the base are injected into the emitter, countering the conversely injected electrons, and thus effectively decreasing the emitter injection efficiency.
- This effect is called *conductivity modulation*.

22

## First Breakdown

- The collector junction supports the off-state voltage and in so doing develops a wide *scl*.
- This *scl* increases in width with increased reverse bias, penetrating into the base.
- It is unusual that a correctly designed high-voltage power switching *BJT* would break down as a result of punch-through of the collector *scl* through the base to the emitter *scl*.

23

## First Breakdown

- Because of the profile of the diffused base, collector junction voltage breakdown is usually due to the avalanche multiplication mechanism, created by the high electric field at the collector junction.
- In the common emitter configuration, the transistor usually breaks down gradually, but before the collector junction avalanches.
- This occurs because the avalanche-generated holes in the collector *scl* are swept by the high-field into the base.

24

## First Breakdown

- The emitter injects electrons in order to maintain base neutrality.
- This emitter junction in turn causes more collector current, creating more avalanche pairs and causing a regenerative action.
- Thus the gain mechanisms of the transistor cause collector emitter breakdown- *first breakdown*

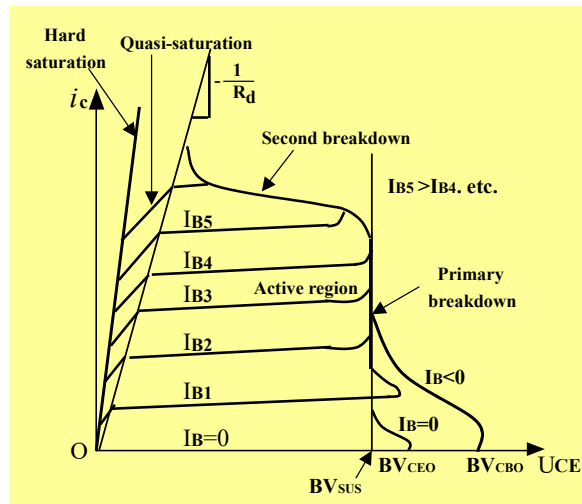
25

## Second Breakdown

- First breakdown need not be catastrophic provided junction temperature limits are not exceeded.
- If local hot spots occur because of non-uniform current density distribution as a result of crystal faults, doping fluctuation etc., *second breakdown occurs.*
- Silicon crystal melting and irreparable damage results, the collector voltage falls and the current increases rapidly as shown in figure below

26

## Second Breakdown



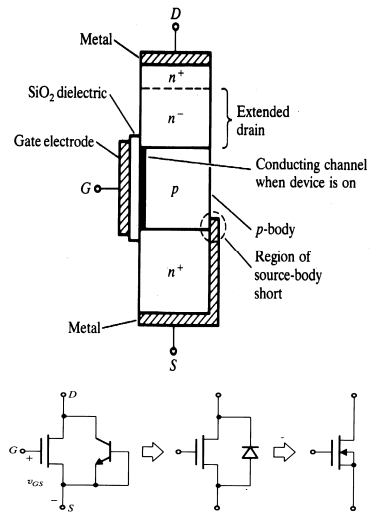
27

# Power MOS

28

## Power MOS

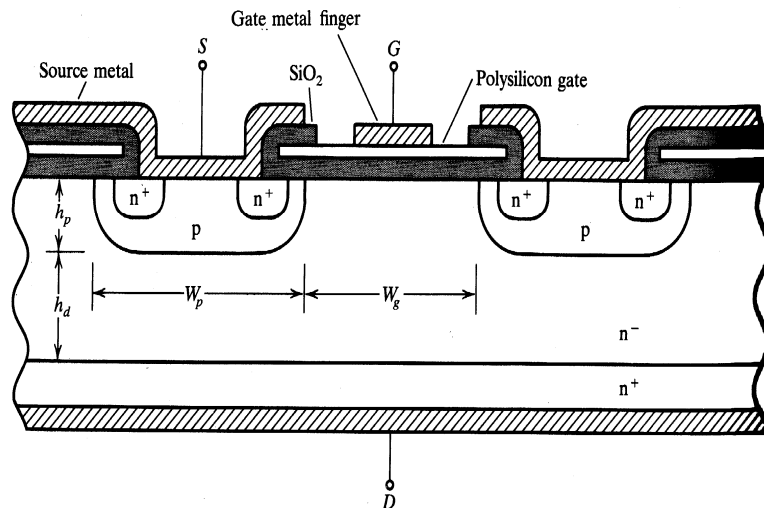
- When positive  $V_{GS}$  is applied, a conducting n-channel is formed beneath the gate in the p-region (body).
- MOSFET turns 'on' when  $V_{GS}$  exceeds  $V_T$ .
- The gate acts like a capacitor.
- The gate power is zero.
- The gate-drive circuit is very simple as compared to BJT.



## Power MOS

- If the MOSFET has to operate at high frequencies, the gate capacitance must be charged and discharged quickly, therefore, the gate drive circuit should have low source impedance.
- When MOSFET is 'on' it acts like a resistor of Value ' $R_{DS(on)}$ '.
- $R_{DS(on)}$  consists of two parts:
  - a) Conducting channel resistance
  - b) Resistance of the extended drain region. Which is unique to Power MOS due to its vertical structure.

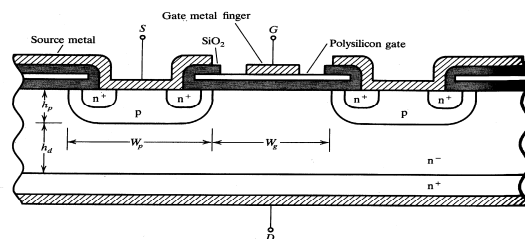
## Power MOS Physical Structure



31

## Power MOS Structure

- The drain contact is on the bottom of the die, rather than on the top as in signal MOSFET.
- This vertical structure gives maximum area to both drain and source contacts.



32



- 
- A detailed cross-sectional diagram of a MOSFET. The structure consists of a substrate with an  $n^-$  layer on top and an  $n^+$  layer at the bottom. A  $p$ -type region is formed in the  $n^-$  layer. On top of the  $p$  region, there are  $n^+$  regions (source and drain) and a central polysilicon gate. A  $SiO_2$  layer covers the top, with a gate metal finger on top of the polysilicon gate. Source metal is connected to the source  $n^+$  region. Dimensions  $W_g$  (gate width) and  $W_d$  (drain width) are indicated. Labels include: Source metal, Gate metal finger,  $SiO_2$ , Polysilicon gate,  $n^+$ ,  $p$ ,  $n^-$ ,  $n^+$ ,  $W_g$ ,  $W_d$ ,  $S$ ,  $G$ ,  $D$ .

# Power MOS

source

channel

n

p

n'

n

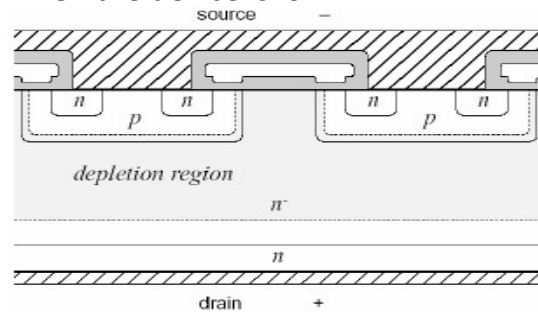
drain

drain current

17

## Power MOS

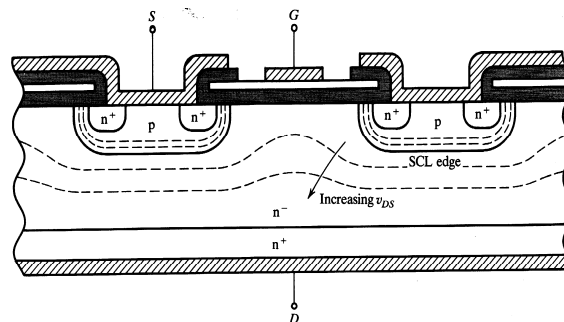
- The lightly doped n-type drain region is unique to Power MOS.
- It will allow the growth of long SCL to block high voltage when the device is 'off'.



35

## Power MOS Under Reverse Biased

Following figure illustrate how the SCL grows with increasing  $V_{DS}$ , pinching off the n- region between the p-wells.



36

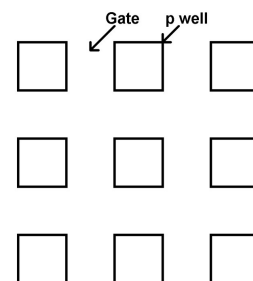
## Power MOS

- The lightly doped drain region is also referred as extended drain region.
- When the device is off, SCL grows and pinches off the region between P-wells.
- The gate electrode acts as a field plate to promote the depletion of the region between p-wells.
- The voltage just beneath the gate oxide is only 5-10 volts w.r.t. gate even though the drain voltage is 200-400V, as a result the gate oxide can be made relatively thin keeping  $V_T$  low.

37

## Power MOS

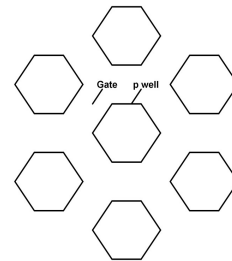
- If viewed from the top, the gate and source contacts look like interleaved pattern of cells as shown in the figure.
- These cells can be arranged in a square pattern.
- For a large power device, the cells can be increased over a large area of the die.
- This is similar to connecting the Power MOS transistors in parallel on a single die to increase the conduction region and power.



38

## Power MOS

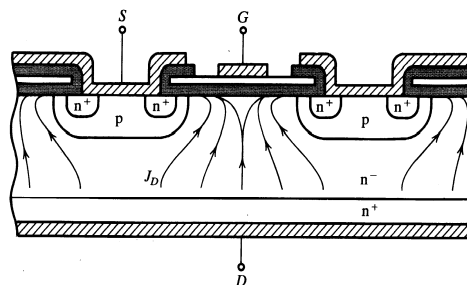
- The p-type wells can also be arranged in hexagonal cell pattern to increase the gate perimeter for a given die area as shown in the diagram.
- This hexagonal structure is a patent of 'International Rectifiers (IR)' for its trademark "HEXFET"



39

## On state Resistance

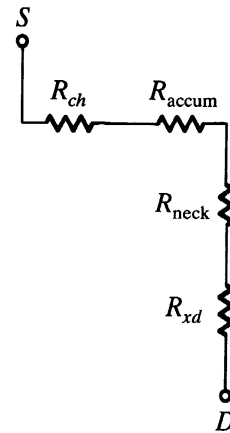
- The drain current distribution when the device is 'on', is shown below.
- The current flows from drain to source when 'on'.
- The current focuses in the area between the p-wells called the neck region.



40

## On state Resistance

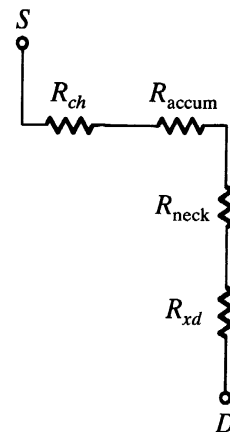
- The current further focuses in the thin entrance to the p-well channels on either sides of the neck regions.
- The n-region just beneath gate is accumulated which makes it much more conductive than rest of the n-region.



41

## On state Resistance

- The total  $R_{DS(on)}$  can be divided into four components as shown in the diagram.
- For high voltage device,  $R_{xd}$  and  $R_{neck}$  are much larger than  $R_{accum}$  and  $R_{ch}$ .
- For low voltage devices,  $R_{ch}$  is  $\frac{1}{3}$  to  $\frac{1}{2}$  of total  $R_{DS(on)}$ .



42

## Temperature Effect

- For high voltage device,  $R_{DS(ON)}$  is dominated by extended drain resistance.
- This on resistance is temperature dependent.
- $R_{DS(ON)}$  increases with temperature.
- A 100 degree rise produces an increase of approximately 90%.

43

## Body Diode

- The connection of the p-wells to the source metal gives the MOSFET an anti-parallel body diode.
- This body diode is a PIN diode as discussed earlier.
- It displays the static and dynamic characteristics of a PIN diode.

44

## Body Diode

- The cross sectional area of
- MOSFET is approximately same as the body diode.
- The body diode displays a reverse recovery phenomenon in the order of 100nS but this is not as short as possible in separate diode.

45

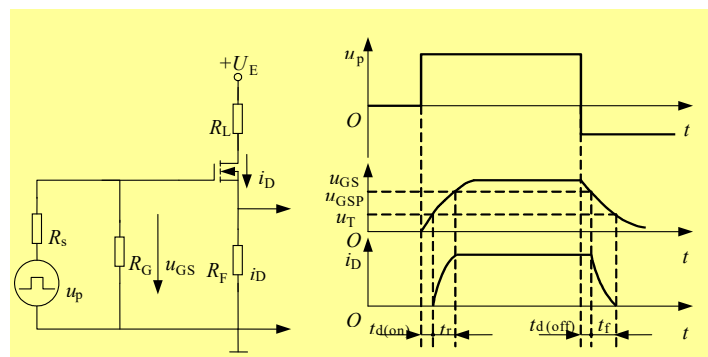
## Switching Characteristics

### Turn- on transient

- Turn- on delay time  $t_{d(on)}$
- Rise time  $t_r$

### Turn- off transient

- Turn- off delay time  $t_{d(off)}$
- Falling time  $t_f$



46

### *Switching Performance*

- The speed at which a Power MOS turns on or off is determined by the rate at which its parasitic capacitance can be charged or discharged.
- The more current the gate drive circuit can deliver or sink, the faster the device switch.

47

### *Switching Performance*

- The gate-drive circuit determines the rise and fall times of the drain current and voltage.
- For instant, if the gate drive is capable to source 1A, and the gate charge is 40nC then;

$$t_f = \frac{40nC}{1A} = 40nS$$

48



# IGBT

*Insulated Gate Bipolar Transistor*

49

## IGBT

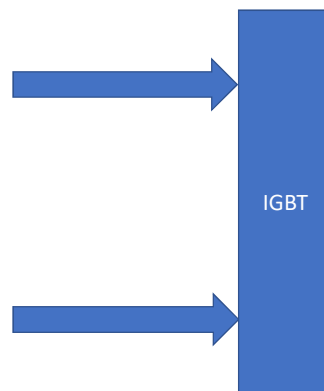
*Combination of MOSFET and Power BJT*

### BJT:

Low conduction losses  
(especially at larger blocking voltages)  
Longer switching times  
Current driven

### MOSFET

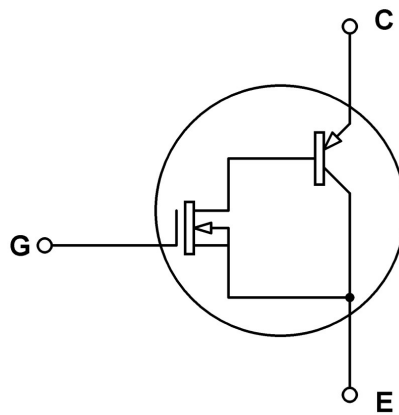
Faster switching speed  
Easy to drive(voltage driven)  
Large conduction losses  
(especially for higher blocking Voltage)



50

## IGBT

IGBT is an integrated Darlington like connection of MOSFET and BJT.



51

## IGBT

- The driving is simple like Power MOS.
- Low forward drop per unit area of BJT.
- Much smaller area results compared to same power MOSFET.

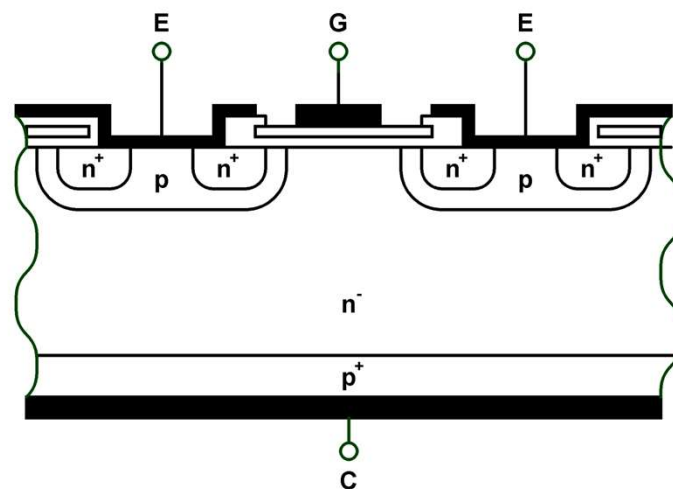
52

## IGBT

- The two transistors are of opposite polarity (n-channel and PNP).
- The gate is driven with respect to collector of BJT.
- Therefore, the collector of BJT is designated as Emitter of IGBT and Emitter of BJT as collector of IGBT.

53

## IGBT Physical Structure



54

## Structure of IGBT

- The structure of IGBT is very much like vertical MOSFET, except that the substrate is heavily doped p-type rather than n-type.
- Integration of two devices rather than discrete connection has an advantage: when the IGBT is on, the BJT is also on conductivity modulating the drift region and greatly reducing the drain resistance of MOSFET.

55

## Structure of IGBT

- If the two devices are connected discretely, the FET un-modulated resistive drop would result in a higher collector-base drop resulting higher  $V_{CE}$  for the Bipolar Transistor.
- One disadvantage of integration is that the structure forces the BJT with wide base.

56

## Structure of IGBT

- Another disadvantage is that the BJT has PNP configuration rather than superior NPN transistor.
- A further problem of integration of the two devices eliminates access to the base terminal of the BJT, preventing the use of negative base current to improve turn-off.

57

## Structure of IGBT

- Turn-off can be improved by reducing the transistor gain but at the expense of on-state drop.
- The integration of two devices produces a parasitic SCR as a regenerative connection of PNP and NPN transistors.

58

- 59

## Structure and Symbol of IGBT



## Structure of IGBT

- If during operation, the current through this region becomes high, the NPN transistor might be turned on, and SCR may latch.
- Once latched, nothing can be done to turn off the device.

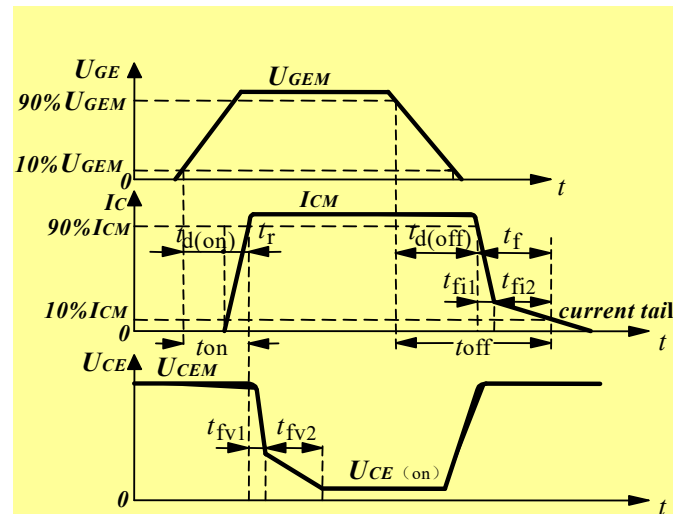
61

## Structure of IGBT

- If the rate of rise of voltage at turn off is high enough, the capacitive charging current could trigger the SCR.
- Even with these problems IGBT has much to offer.
- This device is well suited to high voltage with moderate frequencies  
(1200 V, up to 50KHz.)

62

## IGBT-Switching characteristics



63

## Commercial IGBTs

part number	Rated max voltage	Rated avg current	$V_r$ (typical)	$t_r$ (typical)
Single-chip devices				
HGIG32N60E2	600V	32A	2.4V	0.62 $\mu$ s
HGIG30N120D2	1200V	30A	3.2V	0.58 $\mu$ s
multiple-chip power modules				
CM100HA-12E	600V	400A	2.7V	0.3 $\mu$ s
CMB00HA-24E	1200V	300A	2.7V	0.3 $\mu$ s



Thank you  
*For your attention*

65